PATENT

Attorney Docket No.: 16869V

110400US

Client Reference No.: P04032/USA

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Misako TAMURA, et al.

Examiner:

Application No.:

Art Unit:

Filed:

For: INFORMATION PROCESSING

DEVICE AND METHOD

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97 and §1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that <u>no fee is required</u> for submission of this statement.

However, if a fee is required, the Commissioner is authorized to deduct such fee from Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Misako TAMURA, et al. Application No.: Page 2

Respectfully submitted,

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				Application Number		
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STATEMENT BY APPLICANT				First Named Inventor	Tamura, Misako	
				Art Unit		
(use as many sheets as necessary)				Examiner Name		
Sheet	1	of	1	Attorney Docket Number	16869W-110400US	

U.S. PATENT DOCUMENTS+						
Document Number						
Examiner Initials*	Cite No.1	Number Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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Examiner	Cite No.1	Foreign Patent Document			Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant	
Initials*		Country Code <sup>3</sup>	Number⁴	Kind Code <sup>5</sup> (if known)	MM-DD-YYYY	Applicant of Cited Document	Passages or Relevant Figures Appear	T <sup>6</sup>
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